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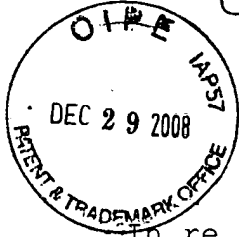
Date

Name

PATENT

Atty. Docket No.: 006915 USA P02/FEP/P3I/PJT

RW Ref. No.: APM/001-02-CP1-2



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kenneth Collins, et al.

Entitled: PLASMA IMMERSION ION
IMPLANTATION APPARATUS USING A
PLASMA SOURCE HAVING LOW
DISSOCIATION AND LOW MINIMUM
PLASMA VOLTAGE

Serial No.: 10/646,533

Filing Date: August 22, 2003

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Group Art Unit: 2893

Examiner: Jack S. Chen

RESPONSE TO DOUBLE PATENTING REJECTION

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action (Double Patenting) dated November 17, 2008, applicants submit herewith a Terminal Disclaimer to overcome the double patenting rejection.

Although the claims have not been amended, a complete listing of claims is provided and begins on page 2.

Remarks begin on page 17 of this paper.